

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Yasuo FUKUDA et al. Group Art Unit : 1792  
Appl. No. : 10/596,280 Examiner : G Nagesh RAO  
Filed : June 8, 2006 Confirmation No. : 4880  
For : EPITAXIAL WAFER AND METHOD FOR PRODUCING SAME

**AMENDMENT UNDER 37 C.F.R. § 1.111**

Commissioner for Patents  
U.S. Patent and Trademark Office  
Customer Service Window, Mail Stop **AMENDMENT**  
Randolph Building  
401 Dulany Street  
Alexandria, VA 22314

Sir:

This Amendment is responsive to the Office Action mailed January 23, 2009. Applicants respectfully request reconsideration and withdrawal of each of the rejections of the outstanding Office Action, and request allowance of all the claims pending herein. Inasmuch as the three-month shortened statutory period is set in the Office Action to expire on April 23, 2009, this response is being filed in a timely manner and no additional fee or extension of time is deemed necessary. Should any extension of time or fees be required to maintain pendency of the application, however, the same is hereby requested and authorization is hereby provided to charge any fees to Deposit Account No. 19-0089.

**Amendments to the Claims** begin on page 2 of this paper.

**Remarks** begin on page 5 of this paper.